



Attorney Docket No. 0756-7197

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Koichiro TANAKA

Serial No. 10/664,916

Filed: September 22, 2003

For: BEAM HOMOGENIZER AND LASER  
IRRADIATION APPARATUS AND  
METHOD OF MANUFACTURING  
SEMICONDUCTOR DEVICE

- ) Group Art Unit: 1722
- ) Examiner: R. Kunemund
- ) CERTIFICATE OF MAILING  
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2006.
- ) John M. Stamps

AMENDMENT

Honorable Commissioner of Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Official Action dated October 6, 2006, please consider the following amendments and remarks in connection with the above-identified application.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 14 of this paper.